



ocket No.:

P2001,0678

at his correspondence is being deposited with the United States Postal Service with sufficient postage as envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 I hereby certify #

Date: April 15, 2004

ATENT AND TRADEMARK OFFICE

Applic. No.

10/813,530

**Applicant** 

Volker Härle, et al. March 29, 2004

Filed Title

Method for Fabricating a Semiconductor Component Based on

a Nitride Compound Semiconductor

Docket No.

P2001,0678

Customer No. :

24131

## **LETTER**

Mail Stop: Missing Parts

Hon. Commissioner for Patents, Alexandria, VA 22313-1450

## Sir:

The above-mentioned new patent application was filed on March 29, 2004 without a signed oath or declaration, under the provision of 37 C.F.R. 1.53(f).

In accordance with the above-mentioned rule, enclosed herewith is the original signed declaration.

The undersigned hereby states that the application filed in the Patent and Trademark Office is the application which the inventor(s) executed by signing the declaration. MPEP 602 (8th ed., Aug. 2001).

The fee required for the late filing of an oath or declaration in the amount of \$130.00 is also enclosed.

Respectfully submitted,

L. MAYBACK

ND. 40,716

Date: April 15, 2004

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